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Attorney Docket No. 252/013

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Hee-Chun LEE

Serial No. 08/825,582

Filed: March 31, 1997

For: SUBSTRATE BIAS GENERATOR IN SEMICONDUCTOR
MEMORY DEVICE

Notice of Allowance Mailed:
September 29, 2004

Previously Pending in
Art Unit: 2816

Examiner: T.D. Cunningham

Confirmation No. 1142

**REQUEST FOR ENTRY OF REFERENCE FROM PREVIOUSLY SUBMITTED
INFORMATION DISCLOSURE STATEMENT UNDER 37 C.F.R. §1.56**

Mail Stop: ISSUE FEE
Commissioner for Patents
Alexandria, VA 22313-1450

Sir:

An Information Disclosure Statement ("IDS") was timely filed on June 30, 1997. A copy of the USPTO receipt evidencing the timely filing of the IDS is attached.

A certified copy of the cited reference, Korean Application No. 13276, together with a full English translation, was submitted with the IDS. Furthermore, the substance of this reference is discussed in the instant specification; see page 9.

Due to the loss of the original PTO file, this file was reconstructed. On September 23, 2003, undersigned counsel filed a Response to Request for Reconstruction which included a complete copy of the entire prosecution file, except for U.S. patent documents. Attached is a copy of the USPTO receipt evidencing the filing of these papers.

In the Notice of Allowability mailed September 29, 2004, the Examiner indicated "The reference filed on the PTO-1449 dated 30 June 1997 has not been considered since the reference is incomplete."

It is respectfully submitted that this reference was complete at the time of its original filing on June 30, 1997, and failure to consider this reference is improper. If, after review of these papers, the Examiner still believes this reference is incomplete, it is respectfully requested that the Examiner indicate what additional material is required.

A complete copy of the Korean application was not kept in applicant's file. If the lack of this complete copy in the reconstructed file* is the reason for refusing consideration, the Examiner is requested to initial the citation under "Other" on the enclosed Form PTO/SB/08 (substitute for Form PTO-1449), which identifies the full English language translation of Korean application No. 13276.


Applicant respectfully requests that the listed document be considered by the Examiner and be made of record in the present application and that an initialed copy of Form PTO-1449 be returned in accordance with MPEP §609.

For the Examiner's convenience, also enclosed are copies of the following

- Information Disclosure Statement filed June 30, 1997
- Photocopy (of identification of) certified copy of KR Application No. 13276 (2 pages)
- English translation submitted with IDS (23 pages text, 8 pages drawing)

Respectfully submitted,

October 21, 2004
Date


Eugene M. Lee
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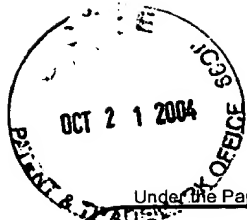
* The *complete certified* copy of the Korean application would have been a part of the original PTO file which the PTO has declared "lost".



DEPOSIT ACCOUNT CHARGE AUTHORIZATION

If fee payment is enclosed, this amount is believed to be correct. However, the Director is hereby authorized to charge any deficiency or credit any overpayment to Deposit Account No. 50-1645.

Any additional fee(s) necessary to effect the proper and timely filing of the above-paper may also be charged to Deposit Account No. 50-1645.



PTO/SB/08B (04-03)

Approved for use through 04/30/2003. OMB 0651-0031

U.S. Patent and Trademark Office; U.S. DEPARTMENT OF COMMERCE

Under the Paperwork Reduction Act of 1995, no persons are required to respond to a collection of information unless it contains a valid OMB control number.

Substitute for form 1449/PTO

**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**

(Use as many sheets as necessary)

Complete if Known

Application Number	08/825,582
Filing Date	March 31, 1997
First Named Inventor	Hee-Chun LEE
Art Unit	2816
Examiner Name	Terry D. Cunningham
Attorney Docket Number	252/013

Sheet

1

of

1

NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
		Full English Translation of Korean Application No. 13276 (23 pages text, 8 pages drawing)(July 1993)	

Examiner
SignatureDate
Considered

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹ Applicant's unique citation designation number (optional). ² Applicant is to place a check mark here if English language Translation is attached. This collection of information is required by 37 CFR 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 120 minutes to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, Washington, DC 20231. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. **SEND TO: Commissioner for Patents, Washington, DC 20231.**

If you need assistance in completing the form, call 1-800-PTO-9199 (1-800-786-9199) and select option 2.

LEE & STERBA, P.C.

Docket No. 252/013

The "Received" stamp of the U.S. Patent & Trademark Office hereon acknowledges receipt of the following:

In re the Application of

Hi-Chun LEE

RECEIVED

Art Unit: 2504

Serial No. 08/825,582

SEP 23 2003

Examiner: Cunningham

Filed: March 31, 1997

OFFICE OF DIRECTOR Confirmation No.
TECHNOLOGY CENTER 2200

For: SUBSTRATE BIAS GENERATOR IN SEMICONDUCTOR MEMORY DEVICE

☒ RESPONSE TO REQUEST FOR RECONSTRUCTION
(Submission Of Duplicate Copy Of Prosecution History) w/photocopy complete file history
(except for U.S. patent documents)

OCT 2 1 2004

RECEIPT FROM PTO FOR INDICATED ITEMS

(Do NOT Use for New or Continuing Applications of Any Kind)
Use 2 postcards for all New Applns. (cont/Div/CIP, too)

Appln. No: 08/825,582 (FWC of 08/691,822)	Attny: MJD
First Inventor: LEE	Date: June 30, 1997
	Matter No: 234072
	Client No: 70691

ENCLOSED:

- ☐ Response/Amendment ☐ Cover Sheet ☐ Cited/Listed Documents
☐ Completion Request for R 53(d)/60(d)/62(d)/PCT Nat.

- # No. of Pages Abstract
No. of Pages Spec and Claims
No. of Numbered Claims Only
No. of Sheets of Drawings (Figs)

- ☐ 1 Set Formal ☐ 1 Set Informal ☐ Cover Letter

- ☐ Declaration # of pages
☐ Assignment Cover Sheet
☐ Small Entity Declaration
☐ Extension Petition (CDC-111)

- # No. of Priority Documents

- ☒ IDS including PTO-1449

- ☒ Cited Documents ☐ Search Report

- ☐ Issue Fee Transmittal Form PTOL-85(b) + (c)

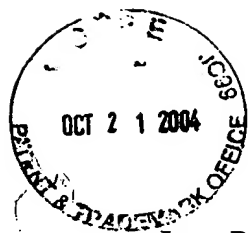
\$ -0- Fee (Check)

OTHER:

Current DUE DATE: June 30, 1997

Submit Single Copy Only





IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
LEE

Group Art Unit: 2504

Examiner: Terry D. Cunningham

Appln. No.: 08/825,582
(FWC of 08/691,822)

Filed: March 31, 1997

For: Substrate Bias Generator in Semiconductor
Memory Device

Date: June 30, 1997

Information Disclosure Statement

Honorable Commissioner of Patents and Trademarks
Washington, D.C. 20231

Sir:

Attached is Form PTO-1449 listing the attached document.

The enclosed document is a certified copy of Korean Application No. 93-13276, which is described at page 9 of the specification. A full English translation of this Korean application is also enclosed.

This IDS is intended to be in full compliance with the rules, but should the Examiner find any part of its required content to have been omitted, prompt notice to that effect is earnestly solicited, along with additional time under Rule 97(f), to enable Applicant to comply fully.

Consideration of the foregoing and enclosures plus the return of a copy of the herewith Form PTO-1449 with the Examiner's initials in the left column per MPEP 609, along with an early action on the merits of this application, are earnestly solicited.

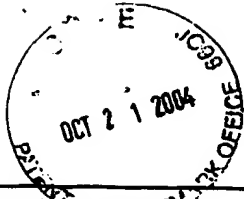
Respectfully submitted,

CUSHMAN DARBY & CUSHMAN
IP Group of Pillsbury Madison & Sutro LLP

By: 

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Washington, D.C. 20005-3918
(202) 861-3000



Form 100 (Continuation Version)

To: U.S. Department of Commerce
Patent and Trademark OfficeAtty.
Dkt. No.

M#

Client Ref.

234072

P3334A/SS/cys

**INFORMATION DISCLOSURE STATEMENT
BY APPLICANT**

Date: June 30, 1997

Page 1 of 1

Applicant: Lee

Appl. No.: 08/825,582 (FWC of 08/691,822)

Filing Date: March 31, 1997

Examiner: Terry D. Cunningham Group Art Unit: 2504

U.S. PATENT DOCUMENTS

Examiner's Initials*		Document Number	Date MM/YYYY	Name (Family Name of First Inventor)	Class	SubClass	Filing Date (if)
	AR						
	BR						
	CR						
	DR						
	ER						
	FR						
	GR						
	HR						
	IR						
	JR						
	KR						
	LR						
	MR						
	NR						

FOREIGN PATENT DOCUMENTS

		Document Number	Date MM/YYYY	Country	Inventor Name	Class	SubClass	English Abstract		Translation Readily Available	
								Enclosed	No	Enclose	No
	OR	13276	07/1993	Korea						X	
	PR										
	QR										
	RR										
	SR										
	TR										
	UR										
	VR										
	WR										
	XR										

OTHER (Including in this order Author, Title, Periodical Name, Date, Pertinent Pages, etc.)

	YR										
	ZR										
	AAR										
	ABR										
	ACR										
	ADR										

Examiner

Date Considered:

*EXAMINER:

Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.